IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Takashi KOBAYASHI et al.

Appln. No.:

Filed: Herewith

For: NONVOLATILE SEMICONDUCTOR MEMORY DEVICE AND MANUFACTURING METHOD THEREOF

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## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the aboveidentified patent application as indicated below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.